

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Kazunari SEKIGAWA, et al.

Serial No. 10/809,372

Group Art Unit: 1756

Confirmation No. 7624

Filed: March 26, 2004

Examiner: YOUNG, CHRISTOPHER G

For: EXPOSING APPARATUS AND EXPOSING METHOD, FOR MASKLESS EXPOSURE
OF SUBSTRATE TO BE EXPOSED, AND PLOTTER AND PLOTTING METHOD FOR
DIRECTLY PLOTTING ON OBJECT TO BE PLOTTED

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

This is in response to the Office Action mailed May 31, 2007, and having a period for response set to expire on June 30, 2007.

The following amendments and remarks are respectfully submitted. Reconsideration of the claims is respectfully requested.